RICH Gas System Design Parameters

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DRY GAS SYSTEM – GENERAL MODEL

[TWO LOGICAL BLOCKS]



DRY GAS SYSTEM BASELINE LAYOUT

[A] FLOW GENERATION AND CONTROL IN OPEN CIRCULATION OPTION



System is flow-driven, i.e. the overpressure is determined by total impedance only. Active controls regulate flow according to overpressure monitors.

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DRY GAS SYSTEM BASELINE LAYOUT

requirements:

Volume of interest ~ 5 m^3

flow:

dry N2 sufficient to keep H2O concentration
below some prefixed level
10 nlm ~ 2 volumes/day

pressure:

wanted levels of ~30-40 mbar are not expected to affect mechanics significantly

components:

- [1] MFC e.g. 50 slm F.S.
- [2] single inlets from two sides w/ internal manifolds
- [2] single outlet from one side w/ internal low impedance manifold
- [3] dP for overpressure measurement at chamber inlets and outlets
- [4] H2O sensor(s) at inlets [0-100 PPM]
- [5] Hydrosorb Molecular sieve(s) for H2O filtration

Central controller: e.g. NI-cRIO



2D idealized model: boundary conditions

Concept is that flow is provided by an inlet tube running along the two sides of the front part of the volume in order to flow around the aerogel plane

FRESH DRY N2 FLOW INLET



Outlet manifolds would run along vertical side collecting the flow streamlines to the outside hall OUTLET MANIFOLD (impedances are considered negligible at this stage) (modeled by continuous boundary towards outer hydrostatic pressure)

2D idealized model





Model is extremely simplified:

inlets are very close to reality (two long inward manifolds)

outlet is to be improved with impedance in order to get realistic inner pressure rise

Overall solution features are realistic and ensure expected outward gas flow



THE RICH Module: Cables Raceways System Details.



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Preliminary general physics shows a temperature of ~40 degC would be kept by a steady 5 degC airflow of ~600 nlm

A more relaxed condition of \sim 60 degC (if acceptable) would be more easily achieved by 20 degC ~500 nlm airflow, certainly avoiding additional technological costs



 $\frac{da}{dt} = G \frac{du}{dt}$

 $\frac{dQ}{dt} =$

(T-T.)

 $\frac{du}{dV} \frac{dV}{dt} (T-T_0) = C_{\theta} \left(\frac{\theta}{2} \right) (T-T_0)$

At

GP (T-T.)